

INFORMATION DISCLOSURE STATEMENT BY APPLICANTS PTO FORM 1449	ATTY. DOCKET NO. 10191/3283	SERIAL NO. Not yet assigned 10/613,459
	APPLICANT(s) Wilhelm FREY et al.	
	FILING DATE Herewith	GROUP Not yet assigned

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
TL	6,210,988	April 3, 2001	Howe et al.	—	—	—

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
						YES	NO
TL	38 74 411*	October 15, 1992	Fed. Rep. of Germany	—	—	Abs.	
TL	0 292 057**	November 23, 1988	Europe	—	—	Abs.	

*Described in Specification

** Corresponds to German Patent No. 38 74 411.

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
TL	Franke et al., "Post-CMOS Modular Integration of Poly-SiGe Microstructures Using Poly-Ge Sacrificial Layers", Solid-State Sensor and Actuator Workshop, Hilton Head, SC, June 2000, pp. 18-21

EXAMINER <i>Thao</i>	DATE CONSIDERED 12/20/04
<small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>	